


<div style="text-align: center;">  <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p> </div>	Docket Number (Optional) P21-155424M/YS	Application Number 10/665,260
	Applicant(s) Kitchiro ITO	
	Filing Date September 22, 2003	Group Art Unit 3677

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/RR/		US-6,119,832	09-2000	Heinz A. Hofmann	188	322.13	
/RR/		US-6,269,919	08-2001	Steven L. Bivens, et al.	188	288	
/RR/		US-6,367,785	04-2002	Isao Nakabayashi, et al.	267	71	
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U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
/RR/		5-76894	10-1993	Japan				✓
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/RR/		Korean Office Action dated September 11, 2006 (with English translation).
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EXAMINER /Ruth Rodriguez/	DATE CONSIDERED 07/17/2007
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.